

<b>Notice of References Cited</b>	Application/Control No.	Applicant(s)/Patent Under Reexamination	
	10/806,269	SIPPOLA, MIKA	
	Examiner	Art Unit	Page 1 of 1
	Marcos D. Pizarro-Crespo	2814	

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	E	US-			
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**FOREIGN PATENT DOCUMENTS**

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